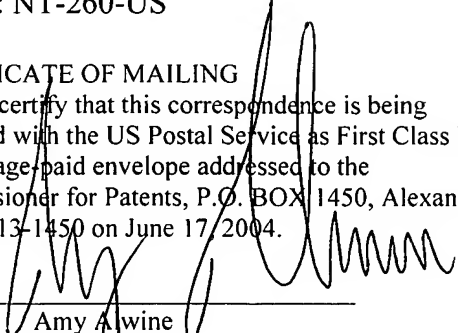




IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

<p>In re application of: Basol et al.</p> <p>Serial No.: 10/654,542</p> <p>Filed: September 2, 2003</p> <p>Title: Constant Low Force Wafer Carrier For Electrochemical Mechanical Processing And Chemical Mechanical Polishing</p>	<p>Group Art Unit: 1753 Examiner: Not yet assigned Docket: NT-260-US</p> <p>CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the US Postal Service as First Class Mail in a postage-paid envelope addressed to the Commissioner for Patents, P.O. BOX 1450, Alexandria, VA 22313-1450 on June 17, 2004.</p> <p>Signed:  Amy A. Wine</p>
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**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. BOX 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants submit information herewith to comply with the obligations set forth in 37 CFR §1.56. This submission is not an admission that any of the documents are prior art or otherwise relevant to the subject application.

This IDS is submitted:

☐ with a filed patent application or within 3 months of the US application filing date;

☒ before the mailing of a first office action on the merits;

☐ after the first office action, but prior to a final rejection or notice of allowance, and is accompanied by the fee set forth in 37 CFR §1.17(p) or a certification set forth below; or

☐ after a final rejection or notice of allowance, and is accompanied by the fee set forth in 37 CFR §1.17(p) and a certification set forth below, where this submission is a petition requesting consideration of this IDS.

If identified above, Applicant certifies that:

☐ the information was first cited in a communication from a foreign patent office in a counterpart foreign application less than 3 months prior to this IDS; or

[ ] to the knowledge of the person signing this certification after making reasonable inquiry, the information was not known to any individuals designated in 37 CFR §1.56 more than 3 months prior to this IDS.

If any matters can be resolved by telephone, Applicant requests that the Patent and Trademark Office call the Applicant at the telephone number listed below.

Respectfully submitted,

By: \_\_\_\_\_

  
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**INFORMATION DISCLOSURE STATEMENT**

**US PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant	
	AA	6,447,379	Sep., 2002	Gromko et al.	Copy Enclosed
	AB	6,443,824	Sep., 2002	Shendon et al.	Copy Enclosed
	AC	6,080,050	Jun., 2000	Chen et al.	Copy Enclosed
	AD	5,916,015	Jun., 1999	Natalicio	Copy Enclosed
	AE	5,423,716	Jun., 1995	Strasbaugh	Copy Enclosed

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant		

**OTHER DOCUMENTS**

Examiner Initials	Cite No.			Trans- lation

Examiner Signature		Date Considered	